| | Multi-paranei siit | Kime-eage |
|------------------------------|---------------------------------|--|
| Effective slit width (s_e) | s | $\left(s + \frac{\ln(2)}{\mu \tan(\alpha)}\right)$ |
| Det. unit FOV | $s\left(1+\frac{d_1}{D}\right)$ | $s_e \left(1 + \frac{d_1}{d_2} \right)$ |
| Lin. collection efficiency | $\frac{Hs}{4\pi LD}(1-f)$ | $\frac{Hs_e}{4\pi Ld_2} \left(1 + x^2/d_2^2\right)^{-3/2}$ |

Effective thickness (T_e)

Multi parallal slit

Knife odgo